

NTIFE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Pan et al.

Serial No.: 09/259,145

Filed: February 26, 1999

For: WELL-DRIVE ANNEAL

TECHNIQUE USING PREPLACEMENT

OF NITRIDE FILMS FOR ENHANCED

FIELD ISOLATION

Examiner: A. Mai

Group Art Unit: 2814

Attorney Docket No.: 3027.1US

(96-684.1)

CERTIFICATE OF MAILING

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October 15, 2001 Date of Deposit

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Joseph A. Walkowski
Typed/printed name of person whose signature is
contained above

AMENDMENT

Box Non Fee Amendment Commissioner for Patents Washington, D.C. 20231

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Office Action mailed July 24, 2001, the three-month shortened statutory period for response to which expires on October 24, 2001.